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APPLICANTS

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** CONTINUING DATA *****
 This appln claims benefit of 60/444,340 01/31/2003

** FOREIGN APPLICATIONS *****
 none, of

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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 7	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged				
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TITLE
 Process for etching polysilicon gates with good mask selectivity, critical dimension control, and cleanliness